

CÓDIGO SERVICIO: 824881

MICRO AND NANOFABRICATION

2024 Rates							
CONCEPT	CUSTOMER						
	ICMM		CSIC		UAM and CSIC Joint Centers (CIF no CSIC)	Spanish public Universities, IMDEA and OPIS	OTHERS
	EUROPEAN PROJECT	NATIONAL PROJECT	EUROPEAN PROJECT	NATIONAL PROJECT			
Rental of space in a controlled environment laboratory (Clean Room) (€/ hour)	3.78	8.47	3.78	9.94	9.94	15.89	17.41
Photolithography: pattern fabrication (€/ hour)	18.20	15.88	18.20	18.63	18.63	44.20	48.41
Metallization (Sputtering): General (€/ process)	18.20	15.88	18.20	18.63	18.63	44.20	48.41
Samples treatment: metallization by evaporation: General (€/ process)	18.20	15.88	18.20	18.63	18.63	44.20	48.41
Physical Vapour Deposition: ALD (atomic layer deposition) (€ / hour)	24.86	15.88	24.86	18.63	18.63	52.83	57.87
Reactive Ion Etching (RIE) (€ / hour)	15.10	15.88	15.10	18.63	18.63	40.17	44.00
Packaging-Assembly: Wire bonding ball (€ / hour)	10.08	15.88	10.08	18.63	18.63	33.66	36.87
Plasma treatment of surfaces (€ / hour)	15.10	15.88	15.10	18.63	18.63	40.17	44.00
Dry box (€ / hour)	3.58	7.41	3.58	8.69	8.69	14.26	15.62